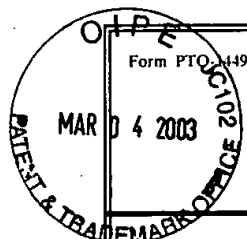


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1427		SERIAL NO. 09/559,903		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Zhiping Yin et al.				
				FILING DATE April 26, 2000		GROUP 2815		
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							Yes	No
gfe	AM	420844A	02-2001	TW				
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	AT							
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PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
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